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PATENT
Atty. Dkt. No. AMAT/8539/TSG/EPI/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Kim, et al.

Serial No.: 10/683,937

Confirmation No.: 2191

Filed: October 10, 2003

For: Method of Selective Deposition of
Heavily Doped Epitaxial SiGe

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

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§ Group Art Unit: 2812
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§ Examiner: Michael M. Trinh
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CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on March 25, 2005 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
<u>3/25/05</u>	<u>Kim 2 2hr</u>
Date	Signature

RESPONSE TO RESTRICTION REQUIREMENT DATED FEBRUARY 25, 2005

In response to the Restriction Requirement dated February 25, 2005, having a shortened statutory period for response set to expire on March 25, 2005, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/8539/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper. **Remarks** begin on page 9 of this paper.